

DOCKET NO: 264741US-2 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
AKIRA AKASAKA, ET AL. : EXAMINER: ELVE, MARIA A.  
SERIAL NO: 10/523,392 :  
FILED: FEBRUARY 3, 2005 : GROUP ART UNIT: 1725  
FOR: LASER PROCESSING :  
APPARATUS, PROCESSING METHOD  
AND METHOD FOR MANUFACTURING  
CIRCUIT BOARD USING SAME

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction requirement of August 23, 2007, Applicants elect,  
without traverse, the invention of Group I, Claims 1-9.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



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